



PATENT

#5
IDS
TRA
3/11/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Young-Jin KIM

Serial No.: 09/599,475

Group Art Unit: 2786 2121

Filed: June 22, 2000

Examiner: Not Yet Assigned

For: SEMICONDUCTOR FACTORY AUTOMATION SYSTEM AND METHOD FOR
MONITORING AT LEAST ONE SERVER IN REAL TIME.

* * * * *

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents **RECEIVED** February 26, 2002
Washington, DC 20231

MAR 01 2002

Sir:

Technology Center 2100

As a means of complying with the duty of disclosure under
37 CFR §1.56, and in accordance with 37 CFR §§1.97 and 1.98,
Applicants, through the undersigned attorney, submits this
Information Disclosure Statement. The patents, publications or
other information submitted herewith are listed on the attached
Form PTO-1449 and copies are attached.

In accordance with 37 CFR §1.97(b) (3), this Information
Disclosure Statement is being filed before the mailing date of a
first Office Action on the merits of the above-identified
application. Should any fee be required by the filing of this
statement, please charge such fee to Deposit Account No. 06-1358.
A duplicate copy of this paper is enclosed.

CERTIFICATION

It is hereby certified that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

JACOBSON, PRICE, HOLMAN & STERN, PLLC

By:


Yoon S. Ham, Registration No. 45,307

The Jenifer Building
400 Seventh Street, N.W.
Suite 600
Washington, D.C. 20004
Tel: (202) 638-66666

Atty. Docket: P65689US0
Enclosures
YSH:ecl